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## APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\*

None *Ⓚ*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2003-062939 03/10/2003

OK *Ⓚ*

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 10/23/2003

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 12	<b>TOTAL CLAIMS</b> 13	<b>INDEPENDENT CLAIMS</b> 3
Verified and Acknowledged	Examiner's Signature <i>Ⓚ</i> Initials <i>Ⓚ</i>				

## ADDRESS

23548

## TITLE

METHOD OF FABRICATING X-RAY MASK AND METHOD OF FABRICATING SEMICONDUCTOR DEVICE  
 USING THE X-RAY MASK

<b>FILING FEE RECEIVED</b> 1550	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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